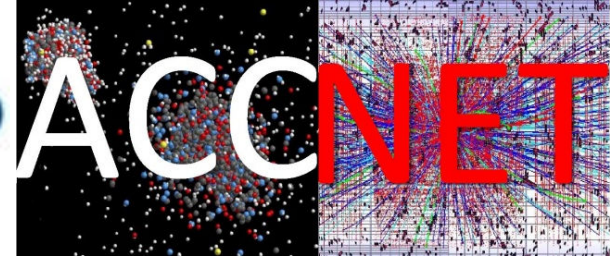




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<http://accnet.lal.in2p3.fr>

accelerator physics, optics and instrumentation challenges

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with

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PPA'09 workshop - partially supported by the European Commission under the FP7 Research Infrastructures project EuCARD, grant agreement no. 227579

optics needs

in front of plasma

- [adjustable] momentum compaction (R_{56}) $\sim 1-5$ m ?

at plasma

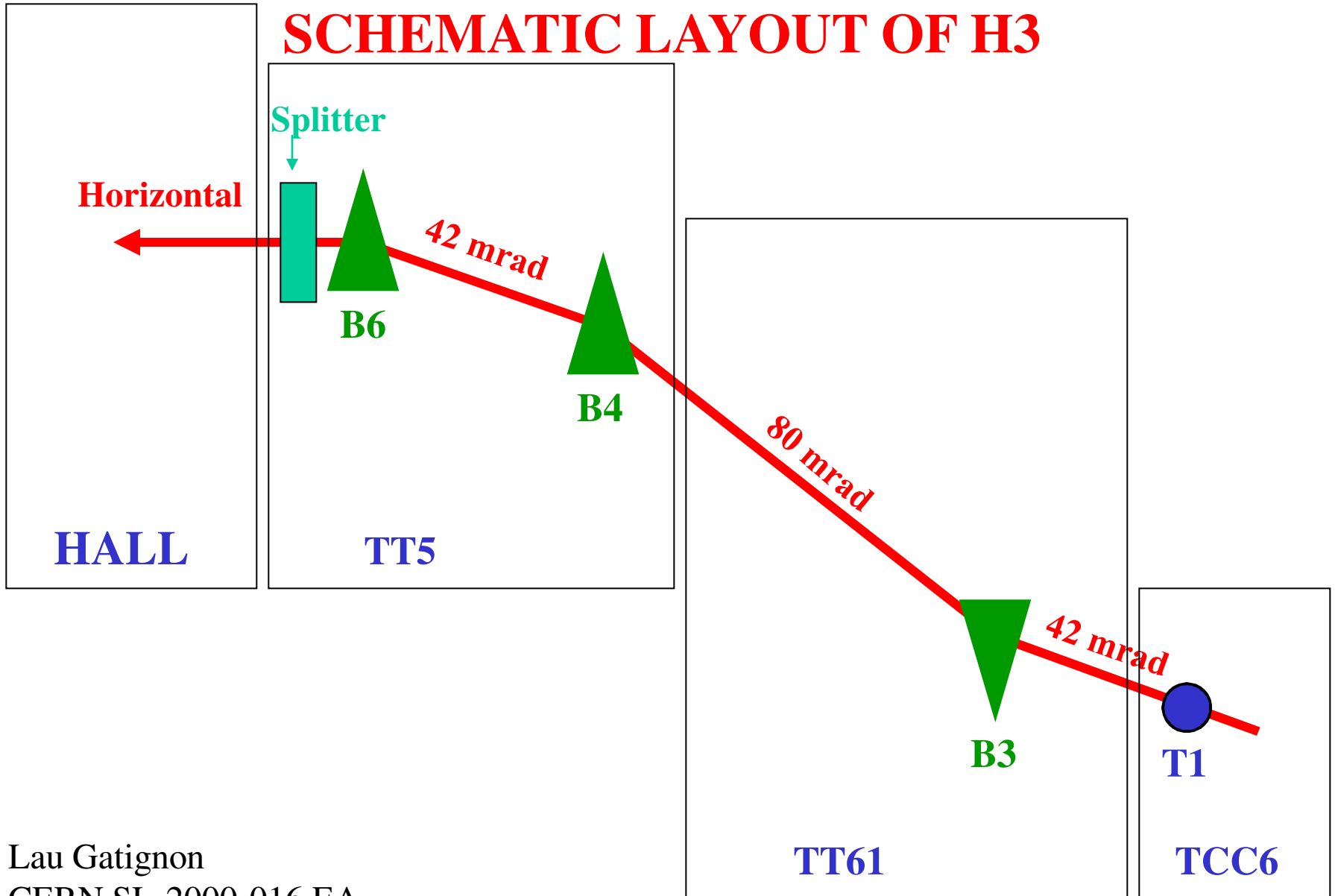
- zero dispersion
- small beta function, but not smaller than plasma length (say ~ 5 m or more)

behind plasma

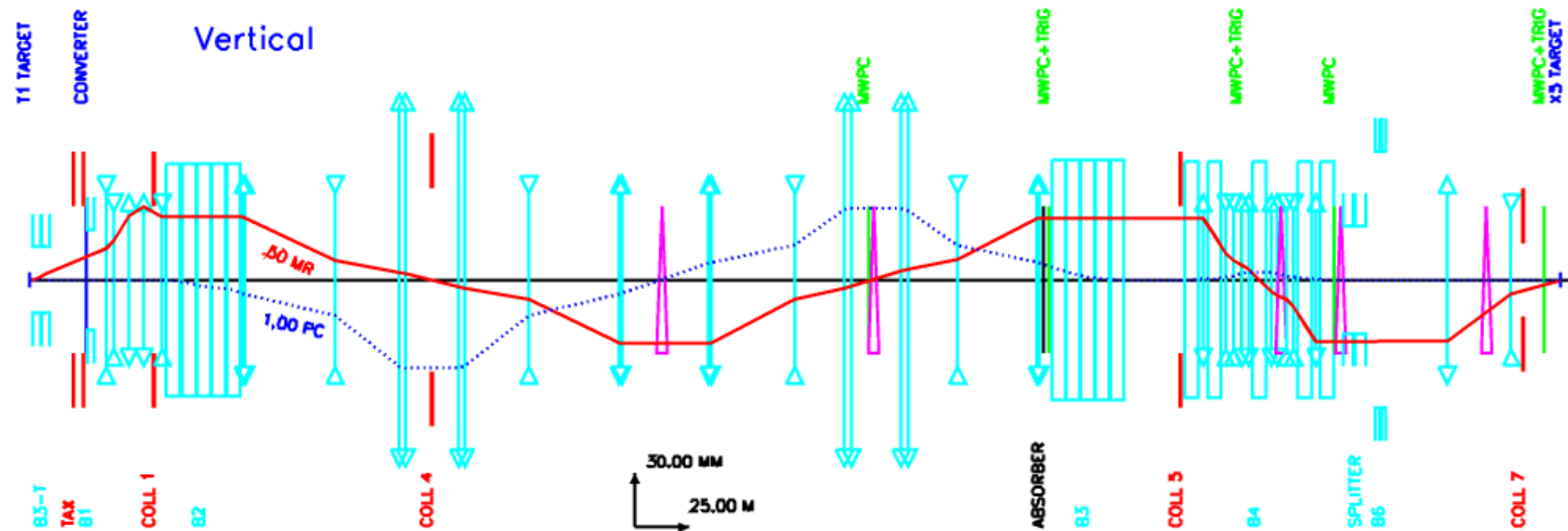
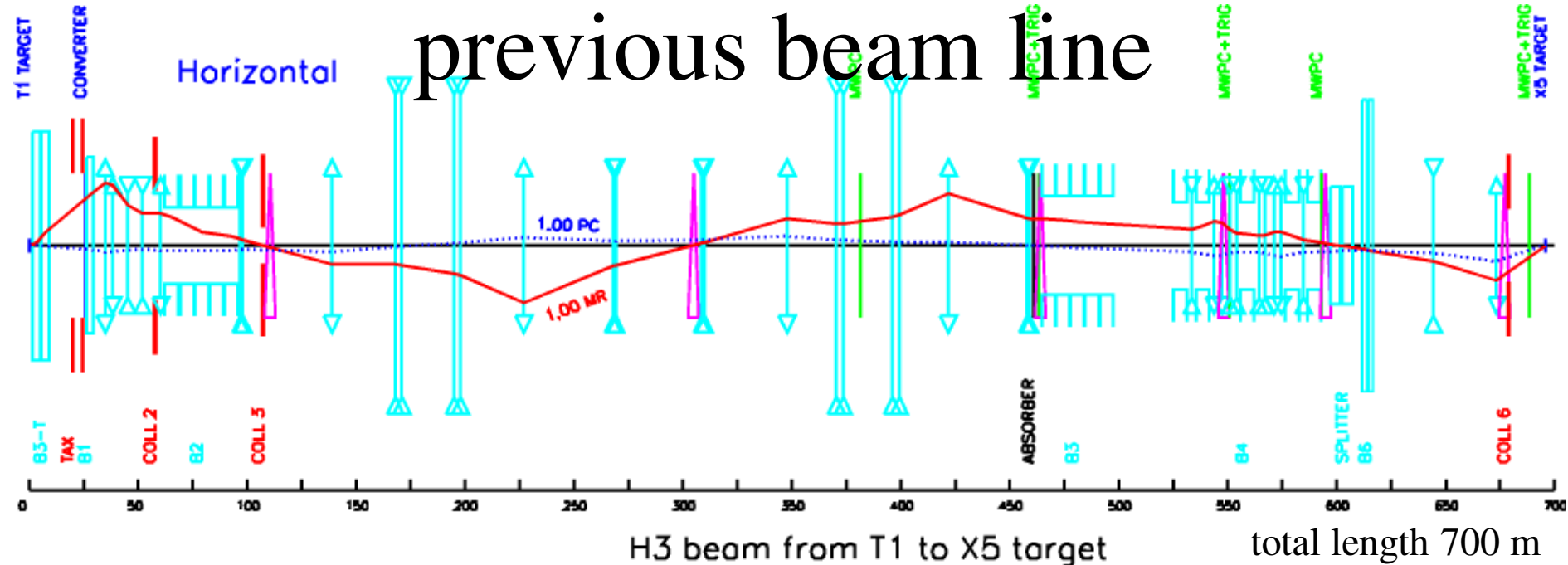
- “spectrometer” with large dispersion; 100 MeV change is $\sim 2 \times 10^{-4}$: dispersion of 1 m would lead to 0.2 mm displacement of particles with 100 MeV offset
- image point, 180 degrees phase advance from plasma (include or not include plasma focusing?); matching of outgoing optics for plasma effect?

previous beam line

SCHEMATIC LAYOUT OF H3



previous beam line



from old to new beam line

total length 700 m

in previous optics:

~zero dispersion from 500 m onward

“cell length” ~ 100 m

for plasma acceleration

plasma around 500 m point?! (or earlier?)

assume 90 degree phase advance / cell

consider FODO optics with **cell length $2L \sim 50$ m**

$\beta_{\max} \sim 85$ m, $\beta_{\min} \sim 15$ m

quadrupole focal strength:
 $1/f \sim 0.057 \text{ m}^{-1}$

$$\beta_{\max} = (2 + \sqrt{2})L \sim 3.4L \quad \beta_{\min} = (2 - \sqrt{2})L \sim 0.6L$$

pole-tip radius $a=2$ cm, magnet length 4 m $\rightarrow B_{\text{tip}} \sim 1.65$ Tesla, OK

may need a special focusing optics to reach $\beta^* \sim 5$ m at plasma

$D \sim \theta_B 4L = 1$ m $\rightarrow I_B = 10$ m with $B = 1.5$ T would suffice

beam parameters

	“LHC” bunch	TOTEM bunch	“LHC” lead bunch
ion	p ⁺	p ⁺	²⁰⁸ Pb ⁸²⁺
energy / nucleon [GeV]	450	450	177.4
ions/bunch [10^{10}]	11.5	3-6	0.007
rms longitudinal emittance/Z [eVs]	0.06	0.02	0.06
rms bunch length [ns]	<0.5	<0.3	0.33
relative rms energy spread [10^{-3}]	0.3	<0.18	0.4
rms transverse emittance [μm]	3.5	1.0	1.4
rms beam size at $\beta^*\sim 5$ m	200 μm	100 μm	200 μm

1 ns = 30 cm, 3×10^{-4} ns = 100 μm

1 bunch every ~ 30 s
or several bunches every 30 s

getting shorter or “better” bunches

- RF bunch compression in beam line
- “shaping” the distribution e.g. steep edge
- bunch rotation via change in RF voltage or momentum compaction prior to extraction
- x(y)-z 4/6-D emittance exchange transformation
- creating microstructure at plasma wavelength
- combination of the above

RF bunch compression in line

minimum bunch length with full compression

$$\sigma_{z,f} = R_{56} \sigma_{\delta,0}$$

(1) require $\sigma_{z,f} = 200 \mu\text{m}$, take $\sigma_{\delta,0} \sim 2 \times 10^{-4}$

$$\rightarrow R_{56} < 1 \text{ m OK}$$

$V_{\text{rf}} f_{\text{rf}} = E c/e/R_{56}/(2\pi)$ for full compression

assume $f_{\text{rf}} = 3 \text{ GHz} \rightarrow V_{\text{rf}} > 7 \text{ GV}$

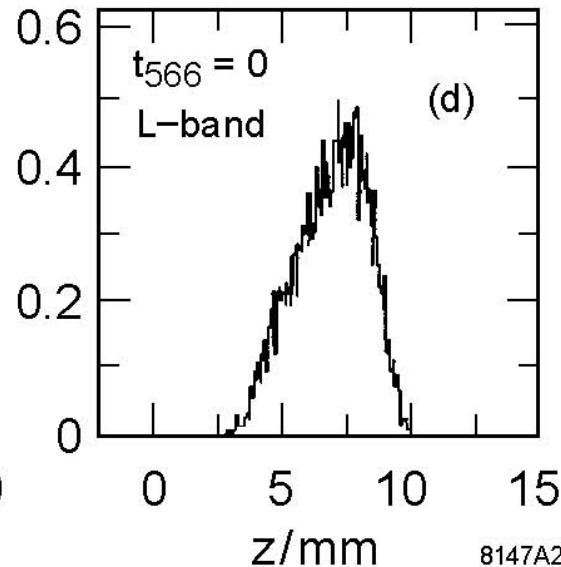
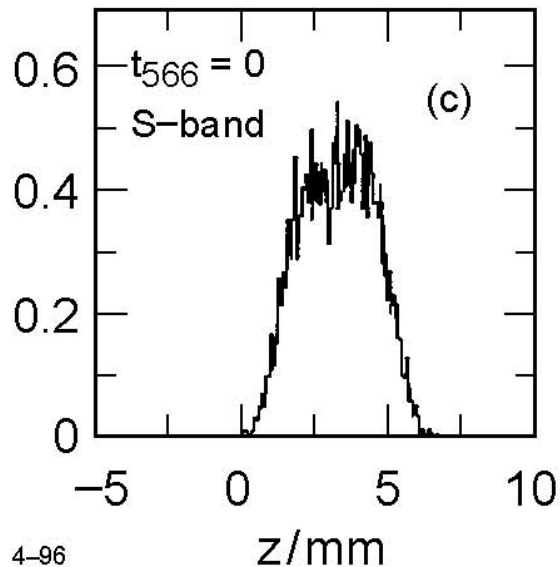
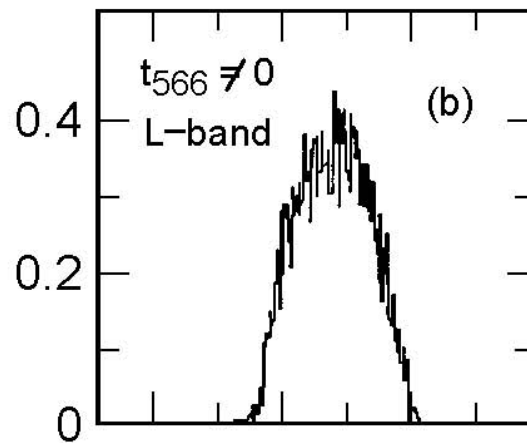
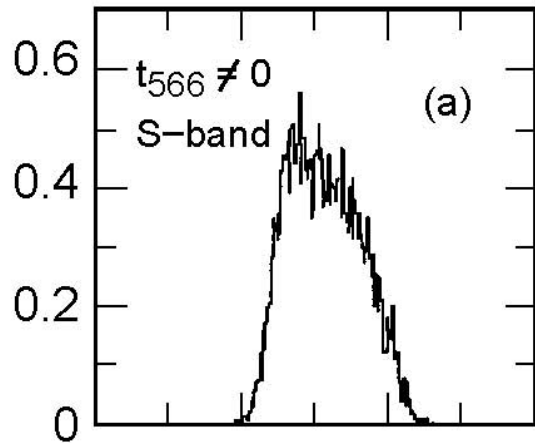
(2) require $\sigma_{z,f} = 1 \text{ mm}$, take $\sigma_{\delta,0} \sim 2 \times 10^{-4}$

$$\rightarrow R_{56} < 5 \text{ m OK} \rightarrow V_{\text{rf}} > 1.4 \text{ GV}$$

with 30 MV/m gradient & 0.65 filling factor

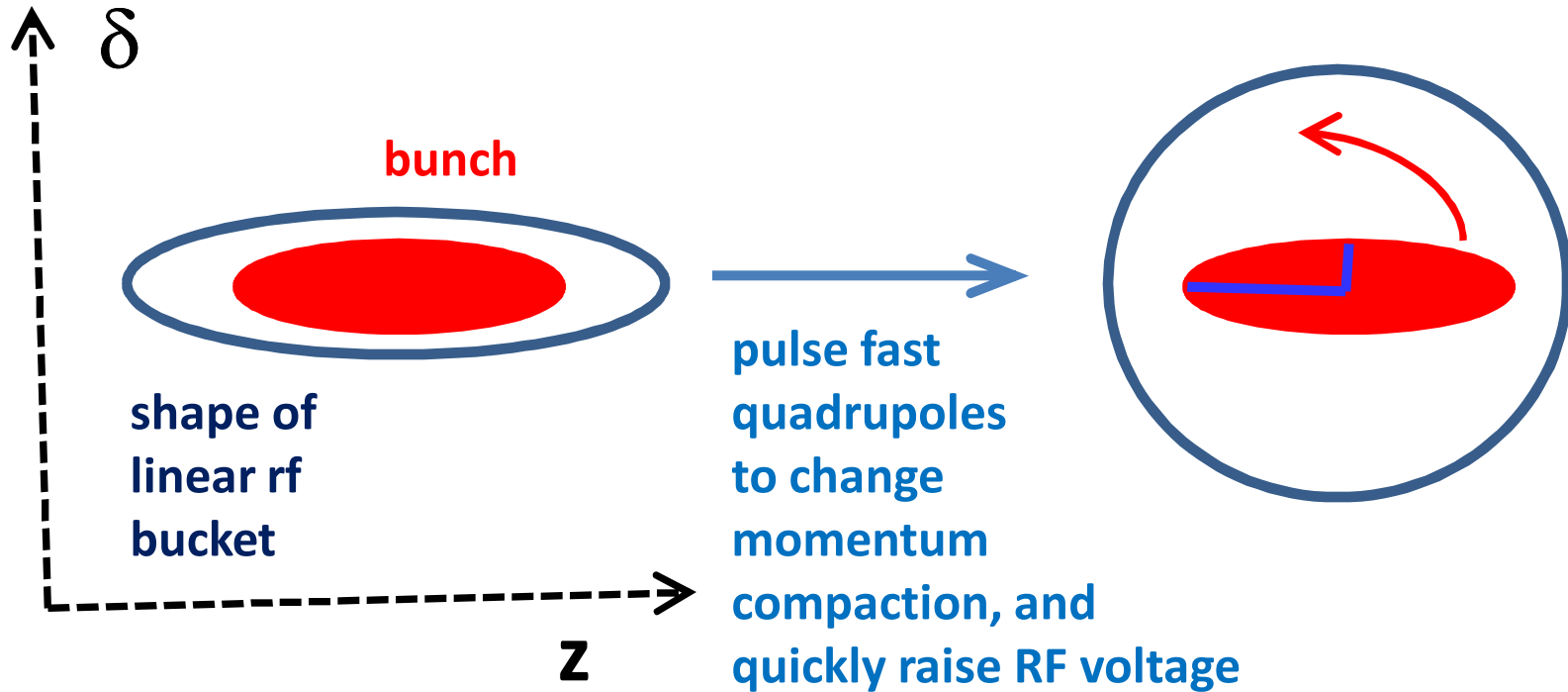
this would need $\sim 75 \text{ m}$ of 3-GHz linac

bunch shaping



modifications of the second order terms allow creating a sharp edge at the start or end of the bunch

bunch rotation prior to extraction



extract after $\frac{1}{4}$ synchrotron oscillation when bunch length is minimum

$$\sigma_{z,\min} \approx 2 \sqrt{\frac{V_{RF,initial} \alpha_{c,new}}{V_{RF,new} \alpha_{c,initial}}} \sigma_{z,initial}$$

bunch length scales with the square root of pulsed momentum compaction factor

SPS initial momentum compaction

$$\alpha_{c,\text{initial}} \sim 0.00186$$

with new optics & additional magnet circuits

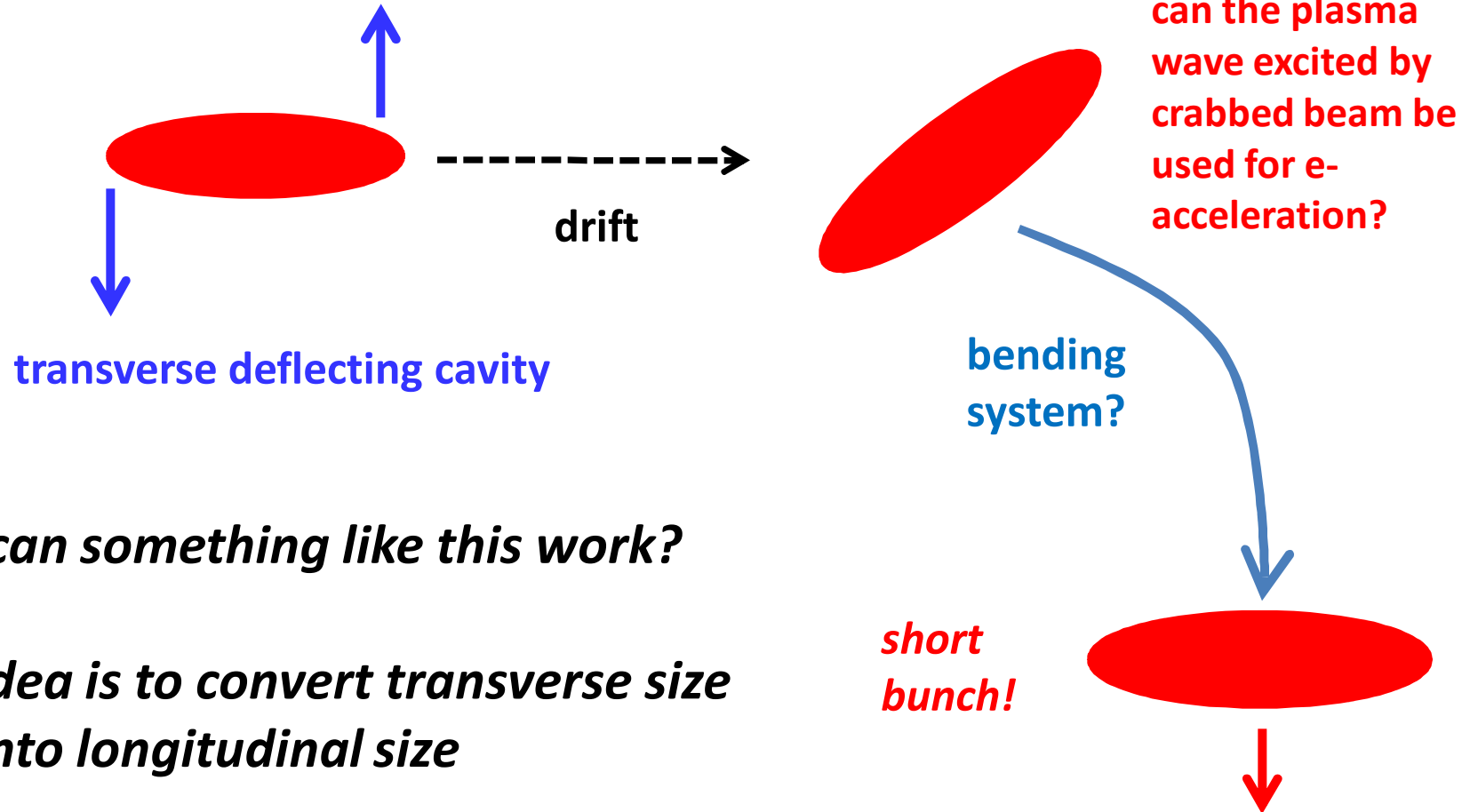
we may hope for $\alpha_{c,\text{new}} \sim 10^{-4}$

initial RF voltage ~ 7 MV

may we “hope” for final RF voltage ~ 10 x
higher (70 MV) ??

→ then expect compression by factor
 $2 \times 10^{-1} / \text{Sqrt}(10) \sim 0.06 \sim 1/16$

transverse deflecting cavity+ bending system



can something like this work?

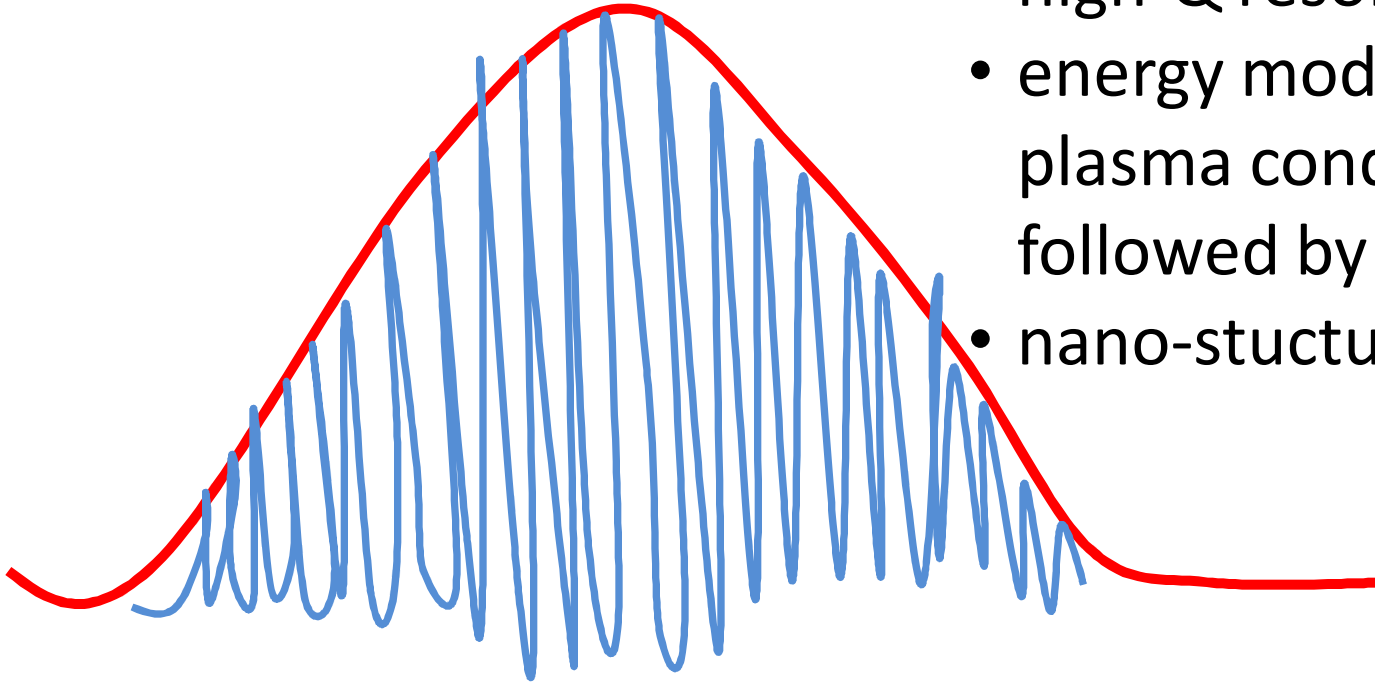
idea is to convert transverse size into longitudinal size

(above schematic ignores x-dependent energy change from crab cavity)

or transverse crab cavity followed by "slit"?

generating microstructure

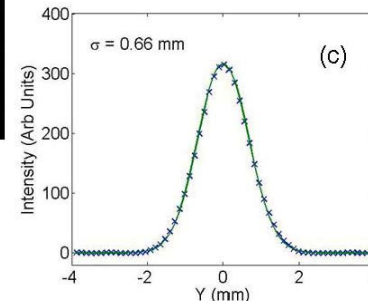
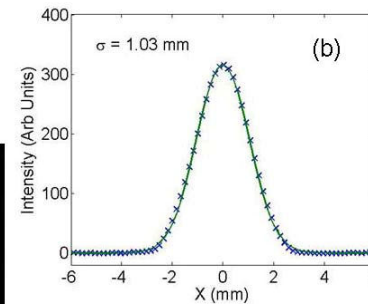
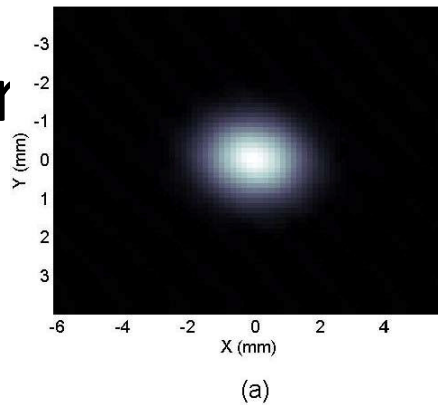
- microwave instability with high-Q resonator
- energy modulation from plasma conditioner followed by bends
- nano-structured chopper



schematic of a bunch with longitudinal microstructure [blue]
superimposed on an original smooth bunch shape [red] —horizontal
axis is time; vertical shows charge density

instrumentation

- beam position monitors along the line
- at spectrometer/image point we need a 2-D profile monitors (OTR or other screen, pixel detector, ...?)
- streak camera?
- or fast kicker for time resolution inside bunch?
- synchrotron radiation from SC bend or plasma?



OTR image
of 150 GeV
protons
at the Tevatron,
(V. Scarpine et al,
2006)

source, optics & instrumentation for e- beam

no work & no thinking done so far (by me at least)

- need space and location for e- injector
- need to match and inject into plasma
- need synchronization and alignment with p beam

some experience from LEP, SLC, CLIC, CTF-3

conclusions

- optics looks feasible; 50 m cell length,
1.65 T pole-tip field
- beam parameter sets
- several schemes for achieving moderate
bunch compression or bunch
shaping
- e- injector & e- optics to be looked at